

JOM Call for papers

An official publication of The Minerals, Metals & Materials Society

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Manuscript Deadline: *July 1, 2018*

**The Nanomaterials Committee
is seeking papers on the topic of
*Application of Atomic Layer
Deposition for Functional
Nanomaterials***

Atomic layer deposition (ALD), an advanced thin film coating method used to fabricate ultrathin, highly uniform and conformal material layers, is increasingly finding unique uses in generating functional nanomaterials. The theme will cover the recent advances in ALD for fabricating functional nanomaterials having novel material properties and technological applications.

Typical paper length is 5,000 to 6,500 words for review papers, and 2,400 to 4,000 words for original papers.

Detailed author instructions are available at:

<http://www.tms.org/AuthorTools/>

Guest Editor for this *JOM* topic is Chang-Yong Nam:
cynam@bnl.gov

If you are interested in submitting a paper, upload your manuscript at
<https://www.editorialmanager.com/jomj/>

Please note that all submissions will be subject to peer review.
Submission does not guarantee acceptance.

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